

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Akira HORIGUCHI et al.

Application No.: 09/743,502

Confirmation No.: 4060

Filed: June 7, 2001

Art Unit: 3723

For: DOUBLE SIDE POLISHING METHOD AND  
APPARATUS

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Examiner: E. A. Ojini

**AMENDMENT UNDER 37 CFR 1.111**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the non-final Office Action dated May 13, 2008, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

Amendments to the Specification begin on page 2.

Amendments to the Drawings begin on page 3.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Remarks begin on page 11 of this paper.